

|    | L # | Hits   | Search Text   | DBs                                     |
|----|-----|--------|---|---|
| 1  | L2  | 36736  | (lcd or liquid adj crystal).ti,ab.  | US-<br>PGPUB;<br>USPAT                  |
| 2  | L3  | 9473   | (tft or thin adj film adj transistor).ti,ab.  | US-<br>PGPUB;<br>USPAT                  |
| 3  | L4  | 3615   | 2 and 3   | US-<br>PGPUB;<br>USPAT                  |
| 4  | L5  | 16753  | selectiv\$6 near2 deposit\$6  | US-<br>PGPUB;<br>USPAT                  |
| 5  | L6  | 52     | 4 and 5   | US-<br>PGPUB;<br>USPAT                  |
| 6  | L7  | 163212 | transparent adj (electrode or conduct\$6)<br>or ito or izo or indium                      | US-<br>PGPUB;<br>USPAT                  |
| 7  | L8  | 243292 | electro or electrodeposit\$8 or<br>electrolytic\$8 or electroform\$8 or<br>electrocoat\$8 | US-<br>PGPUB;<br>USPAT                  |
| 8  | L9  | 2948   | 7 with 8  | US-<br>PGPUB;<br>USPAT                  |
| 9  | L10 | 45     | 4 and 9   | US-<br>PGPUB;<br>USPAT                  |
| 10 | L11 | 332714 | lcd or liquid adj crystal   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 11 | L12 | 44663  | tft or thin adj film adj transistor   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 12 | L13 | 3728   | selectiv\$6 near2 deposit\$6  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |

|    | L # | Hits   | Search Text   | DBs                                     |
|----|-----|--------|---|---|
| 13 | L14 | 20     | 11 and 12 and 13  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 14 | L15 | 257989 | transparent adj (electrode or conduct\$6)<br>or ito or izo or indium  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 15 | L16 | 184668 | electro adj (deposit\$8 or form\$6 or<br>coat\$6) or electrodeposit\$8 or<br>electrolytic\$8 or electroform\$8 or<br>electrocoat\$8 | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 16 | L17 | 35     | 11 and 12 and 15 and 16   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |

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|----|-----|---------|--|------------------------|
| 1  | L1  | 36736   | (lcd or liquid adj crystal).ti,ab.   | US-<br>PGPUB;<br>USPAT |
| 2  | L2  | 9473    | (tft or thin adj film adj transistor).ti,ab.   | US-<br>PGPUB;<br>USPAT |
| 3  | L3  | 163212  | transparent adj (electrode or conduct\$6)<br>or ito or izo or indium   | US-<br>PGPUB;<br>USPAT |
| 4  | L5  | 4442846 | metal\$4 or wire or wiring or al or cu or<br>ag or mo or cr or ti or w or aluminum or<br>copper or silver or molybdenum or<br>chromium or titanium or tungsten   | US-<br>PGPUB;<br>USPAT |
| 5  | L11 | 1354426 | mask\$4 or pattern\$4 or resist or<br>photoresist  | US-<br>PGPUB;<br>USPAT |
| 6  | L15 | 186017  | electro adj (deposit\$8 or coat\$4 or<br>form\$6 or plat\$4 or chemical\$8) or<br>electrodeposit\$8 or electrolytic\$8 or<br>electroform\$8 or electrocoat\$8 or<br>electroplat\$8 or electrochemical\$8 | US-<br>PGPUB;<br>USPAT |
| 7  | L16 | 95386   | 15 with 5  | US-<br>PGPUB;<br>USPAT |
| 8  | L17 | 1954    | 3 same 16  | US-<br>PGPUB;<br>USPAT |
| 9  | L18 | 41      | 1 and 2 and 17   | US-<br>PGPUB;<br>USPAT |
| 10 | L19 | 85459   | gate adj electrode   | US-<br>PGPUB;<br>USPAT |
| 11 | L20 | 455     | 15 with 19   | US-<br>PGPUB;<br>USPAT |
| 12 | L21 | 17      | 20 same 3  | US-<br>PGPUB;<br>USPAT |
| 13 | L22 | 798960  | deposit\$8   | US-<br>PGPUB;<br>USPAT |
| 14 | L23 | 296     | 3 with 19 with 22  | US-<br>PGPUB;<br>USPAT |

|    | L # | Hits   | Search Text   | DBs                                     |
|----|-----|--------|---|---|
| 15 | L24 | 86     | 1 and 2 and 23  | US-PGPUB;<br>USPAT                      |
| 16 | L25 | 86     | 24 not (18 or 21)   | US-PGPUB;<br>USPAT                      |
| 17 | L26 | 16753  | selectiv\$6 near2 deposit\$6  | US-PGPUB;<br>USPAT                      |
| 18 | L27 | 418    | 19 with 26  | US-PGPUB;<br>USPAT                      |
| 19 | L28 | 4      | 1 and 2 and 27  | US-PGPUB;<br>USPAT                      |
| 20 | L29 | 536    | ((a or amorphous) and (poly or polycrystal\$8)) adj (si or silicon)).ti,ab. | US-PGPUB;<br>USPAT                      |
| 21 | L30 | 44     | 1 and 2 and 29  | US-PGPUB;<br>USPAT                      |
| 22 | L31 | 332714 | lcd or liquid adj crystal   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 23 | L32 | 44663  | tft or thin adj film adj transistor   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 24 | L33 | 257989 | transparent adj (electrode or conduct\$6) or ito or izo or indium           | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 25 | L34 | 90585  | gate adj electrode  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |

|    | L # | Hits    | Search Text  | DBs                                     |
|----|-----|---------|--|---|
| 26 | L35 | 251998  | electro adj (deposit\$8 or coat\$4 or form\$6 or plat\$4 or chemical\$8) or electrodeposit\$8 or electrolytic\$8 or electroform\$8 or electrocoat\$8 or electroplat\$8 or electrochemical\$8 | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 27 | L36 | 8       | 32 and 33 and 34 and 35  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 28 | L37 | 6156190 | metal\$4 or wire or wiring or al or cu or ag or mo or cr or ti or w or aluminum or copper or silver or molybdenum or chromium or titanium or tungsten  | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 29 | L39 | 8       | 31 and 32 and (33 with 35 with 37)   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 30 | L40 | 475022  | deposit\$8   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 31 | L41 | 37      | 31 and 32 and (33 with 34 with 40)   | EPO;<br>JPO;<br>DERWE<br>NT;<br>IBM_TDB |
| 32 | L42 | 5666    | 430/313,314,315,317,319,321.ccls.  | US-<br>PGPUB;<br>USPAT                  |
| 33 | L43 | 24      | 1 and 2 and 42   | US-<br>PGPUB;<br>USPAT                  |
| 34 | L44 | 8519    | (transparent adj (electrode or conduct\$6) or ito or izo or indium).ti,ab.   | US-<br>PGPUB;<br>USPAT                  |

|    | L # | Hits | Search Text                  | DBs                    |
|----|-----|------|------------------------------|------------------------|
| 35 | L45 | 28   | 1 and 42 and 44              | US-<br>PGPUB;<br>USPAT |
| 36 | L49 | 1535 | lee-chi\$.in.                | US-<br>PGPUB;<br>USPAT |
| 37 | L50 | 84   | wu-yung\$.in.                | US-<br>PGPUB;<br>USPAT |
| 38 | L51 | 3810 | chen-chi\$.in.               | US-<br>PGPUB;<br>USPAT |
| 39 | L52 | 427  | chen-cheng\$.in.             | US-<br>PGPUB;<br>USPAT |
| 40 | L53 | 132  | (49 or 50 or 51 or 52) and 1 | US-<br>PGPUB;<br>USPAT |
| 41 | L54 | 17   | 53 and (2 or 44)             | US-<br>PGPUB;<br>USPAT |
| 42 | L55 | 948  | 438/30.ccls.                 | US-<br>PGPUB;<br>USPAT |
| 43 | L56 | 75   | 2 and 44 and 55              | US-<br>PGPUB;<br>USPAT |